

## Update on Analysis of Low RRR SRF Cavities

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TTC2023 at Fermilab

5 December 2023

In partnership with:



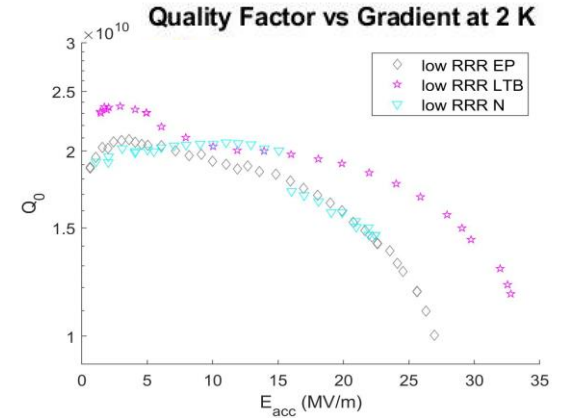
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# Continuation of Low RRR Studies

- Many SRF studies follow a “clean bulk dirty surface” technique to optimize the BCS resistance by adding extrinsic impurities
  - Low temperature bake and N-doping are current focus
- What role do intrinsic impurities serve?
  - Might perform similar functions as extrinsic impurities which have been shown to improve performance
- Goal: use understanding of intrinsic impurities to design future surface treatments for high gradient and quality factor
  - Taking new avenue by studying low RRR cavities
  - Low purity Nb → increased concentration of **intrinsic** impurities
  - Taking a deep dive in characterizing performance with TMAP

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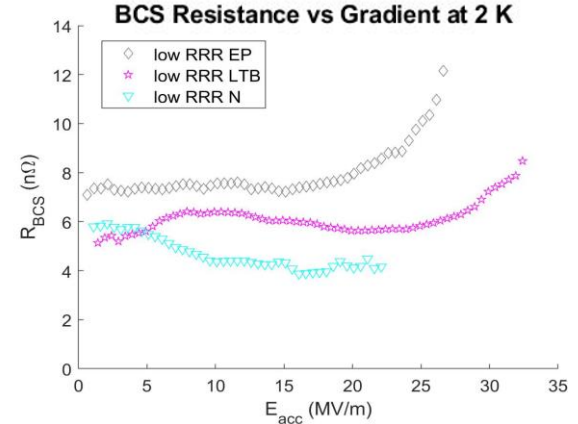


Surface treatments appear to vary cavity performance, but slightly differently when compared to high RRR cavities

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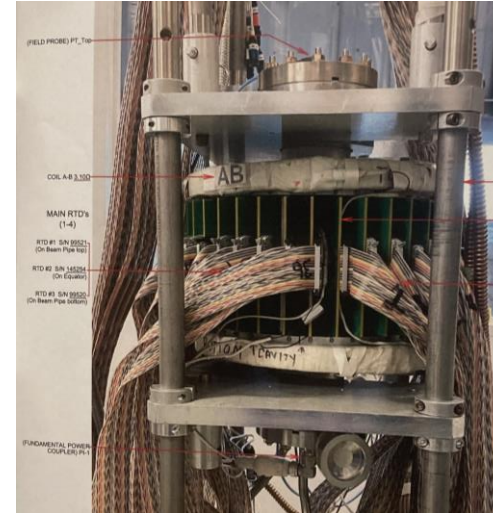
Observe many of the phenomena characteristic of each treatment, but again to slightly different extents



# Using TMAP to Further Characterize Performance of Low RRR Cavities

# Sequential TMAP Study on Single Low RRR Nb SRF Cavity

- 1.3 GHz TESLA-shaped single-cell low RRR (= 61) cavity
- RF testing after surface treatments
  - Electropolished (40  $\mu\text{m}$  EP for baseline)
  - Low temperature bake (120  $^{\circ}\text{C}$  x 48 hours)
  - N-doping (2/6 recipe with 5  $\mu\text{m}$  EP)
  - Underdoped (additional 2  $\mu\text{m}$  EP from N-doped surface)



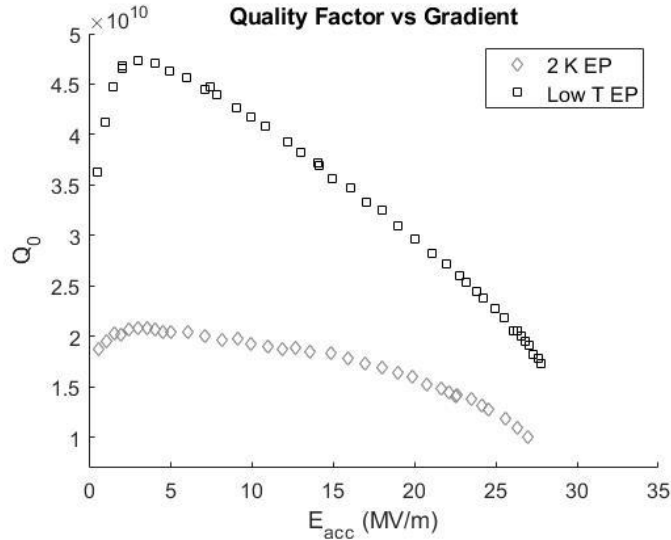
16 RTD's  
per board

36 boards



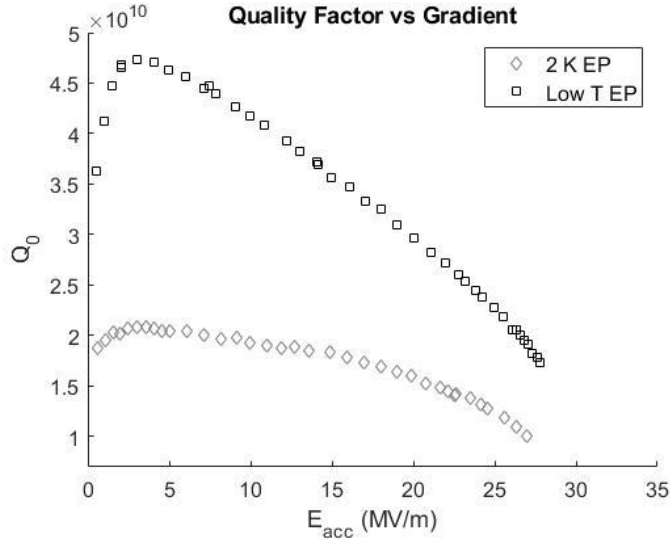
# Sequential TMAP Study 1/4: EP

- Cavity received 40  $\mu\text{m}$  EP to reset surface
- Low RRR has slightly lower  $Q_0$  than high RRR
- $Q_0$  slope begins sooner but less sharp than high RRR



# Sequential TMAP Study 1/4: EP

- Cavity received 40  $\mu\text{m}$  EP to reset surface
- More localized heating but not only at quench location

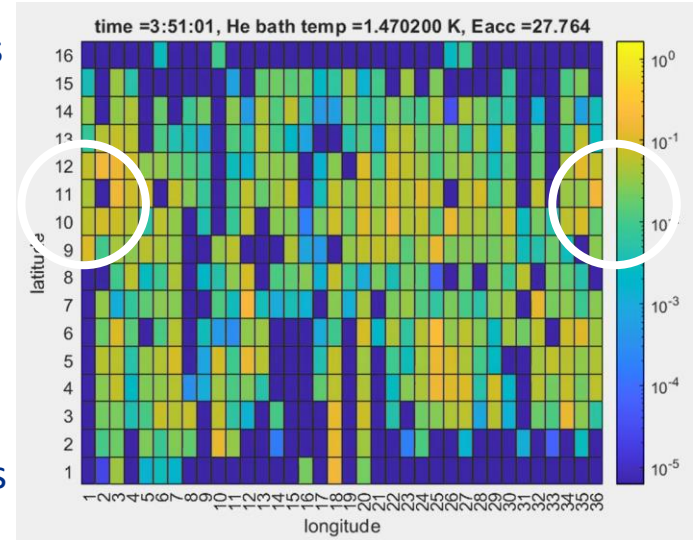


## TMAP Profile Just Before Quench

top iris

equator

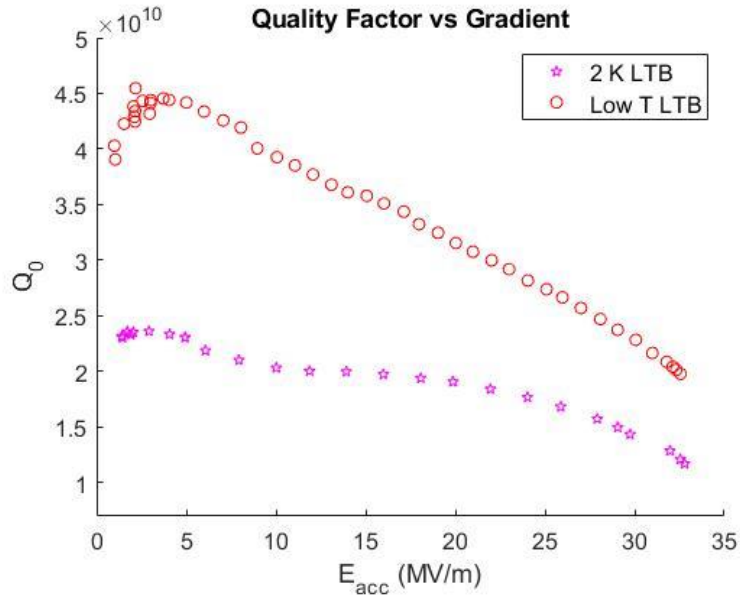
bottom iris





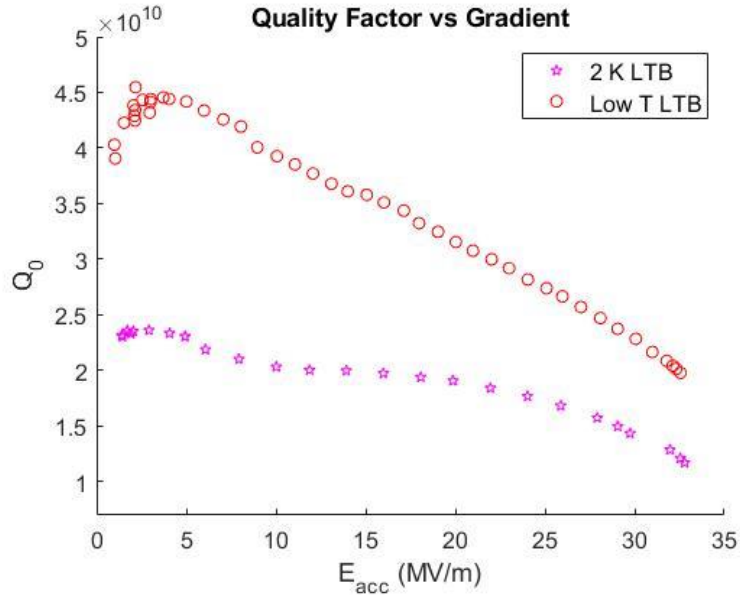
# Sequential TMAP Study 2/4: LTB

- Low temperature bake (120 °C x 48 hours)
- Low RRR experiences reduced response to LTB treatment



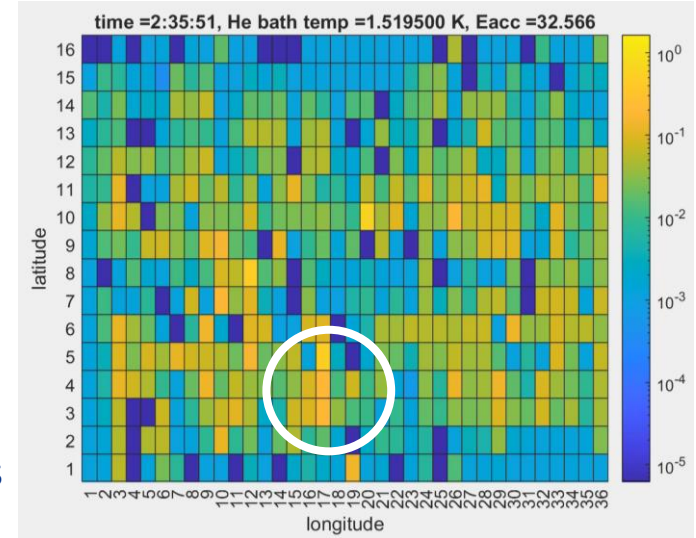
# Sequential TMAP Study 2/4: LTB

- Low temperature bake (120 °C x 48 hours)
- More widespread heating, including at quench location



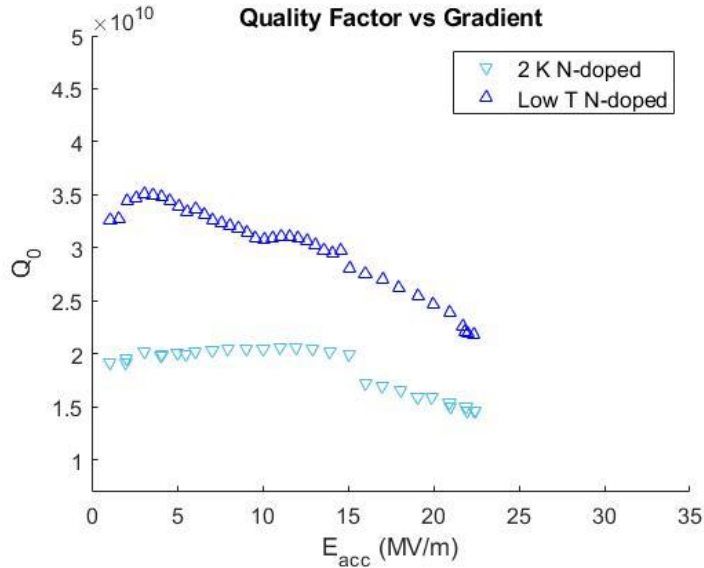
## TMAP Profile Just Before Quench

top iris  
equator  
bottom iris



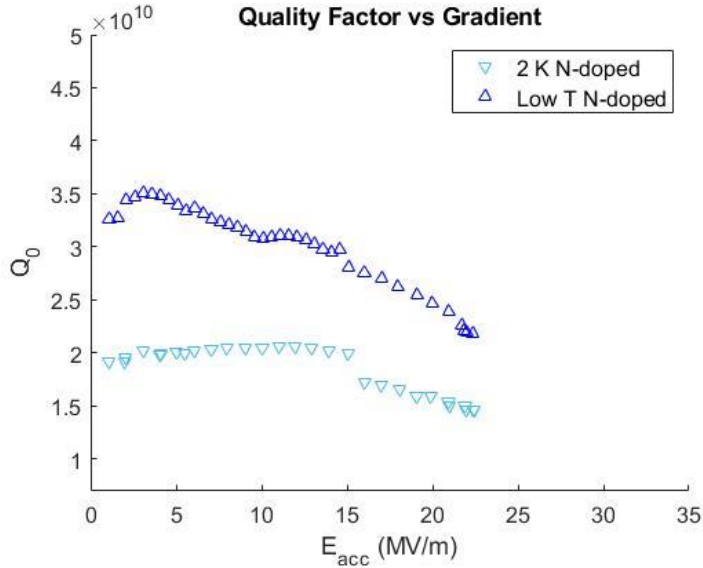
# Sequential TMAP Study 3/4: N-doped

- N-doping 2/6 recipe with 5  $\mu\text{m}$  EP
- Much lower  $Q_0$  than high RRR but similar gradients reached



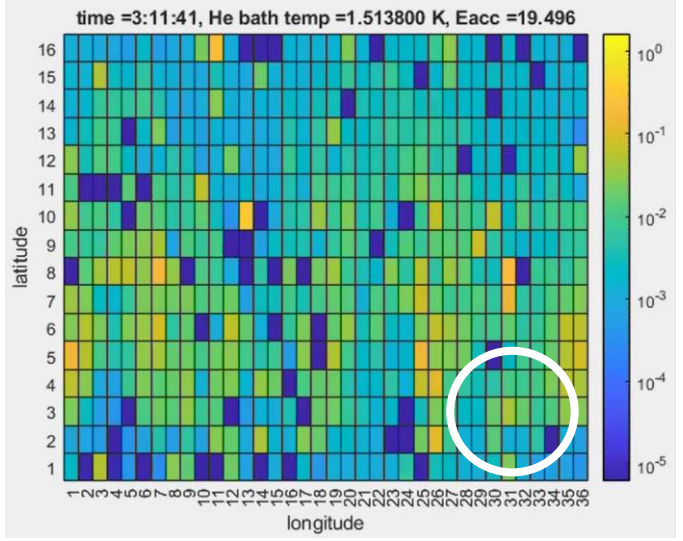
# Sequential TMAP Study 3/4: N-doped

- N-doping 2/6 recipe with 5  $\mu\text{m}$  EP
- More widespread heating, not specifically at quench location



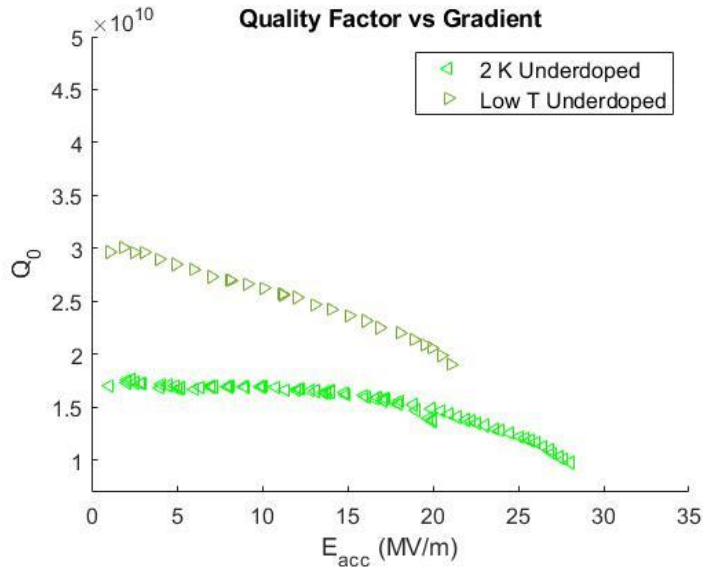
top iris  
equator  
bottom iris

## TMAP Profile Just Before Quench



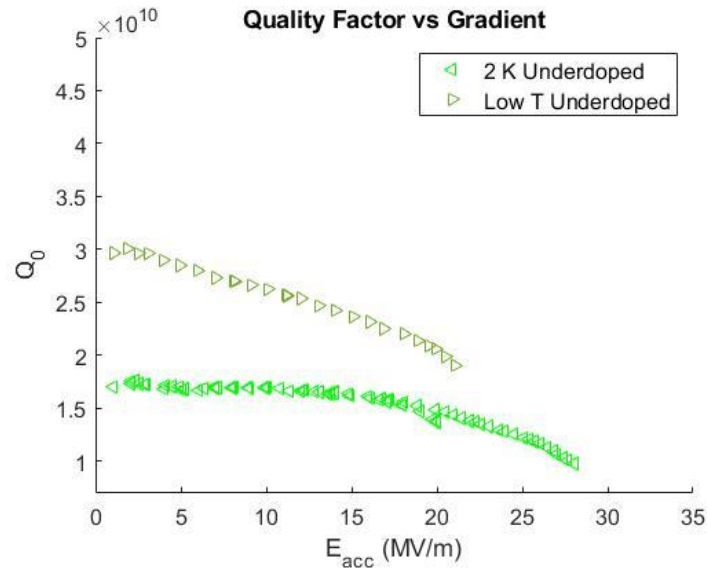
# Sequential TMAP Study 4/4: Underdoped

- Underdoped (additional 2  $\mu\text{m}$  EP from N-doped surface) to see how decreasing N concentration changes performance
- Significantly lower  $Q_0$  but reaches higher gradient than N-doped



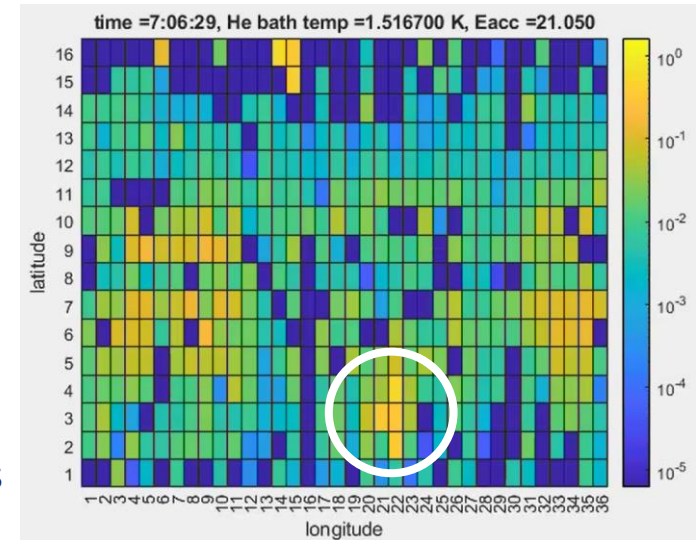
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- Underdoped (additional 2  $\mu\text{m}$  EP from N-doped surface) to see how decreasing N concentration changes performance
- More localized heating, including at quench location

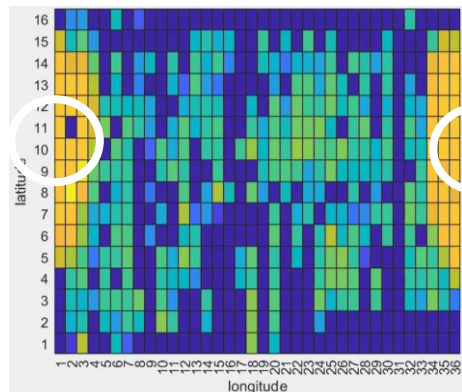


top iris  
equator  
bottom iris

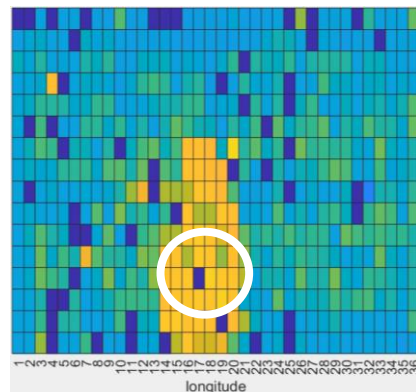
## TMAP Profile Just Before Quench



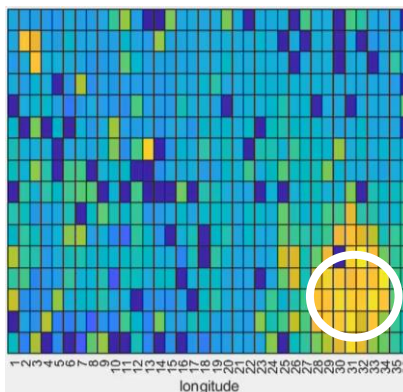
# Comparing TMAPs for All Studied Treatments



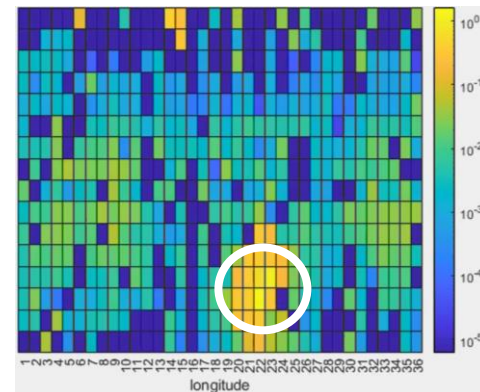
EP



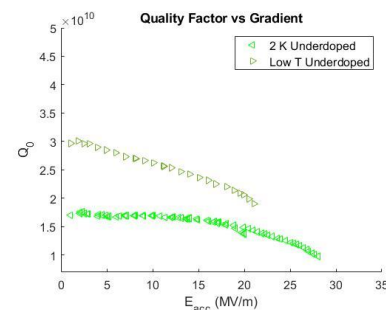
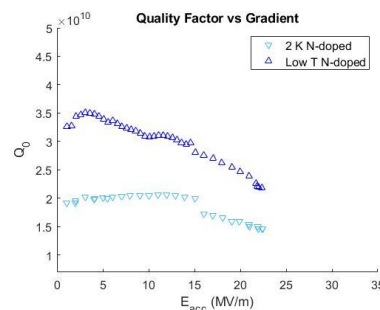
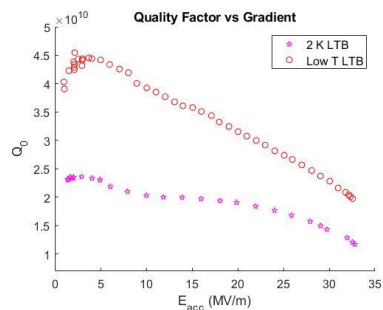
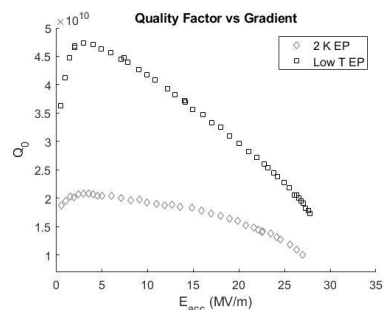
LTB



N-doped

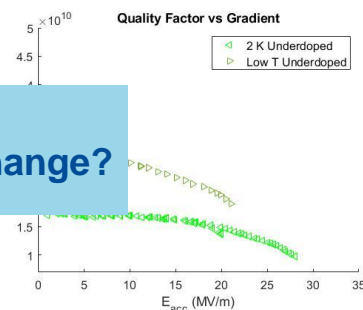
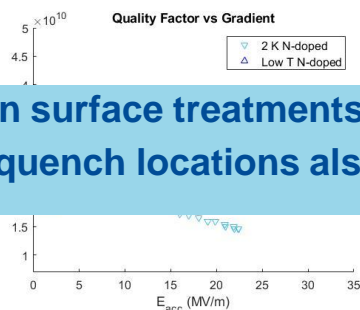
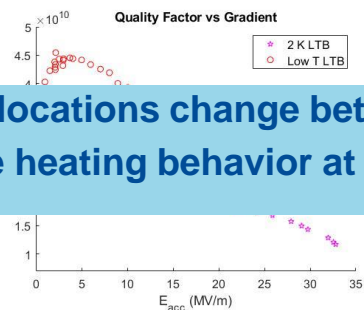
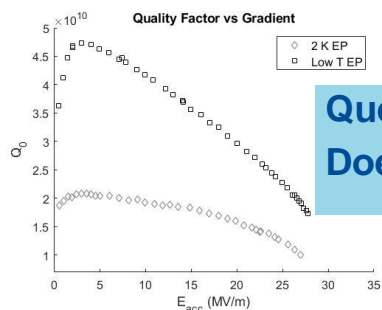
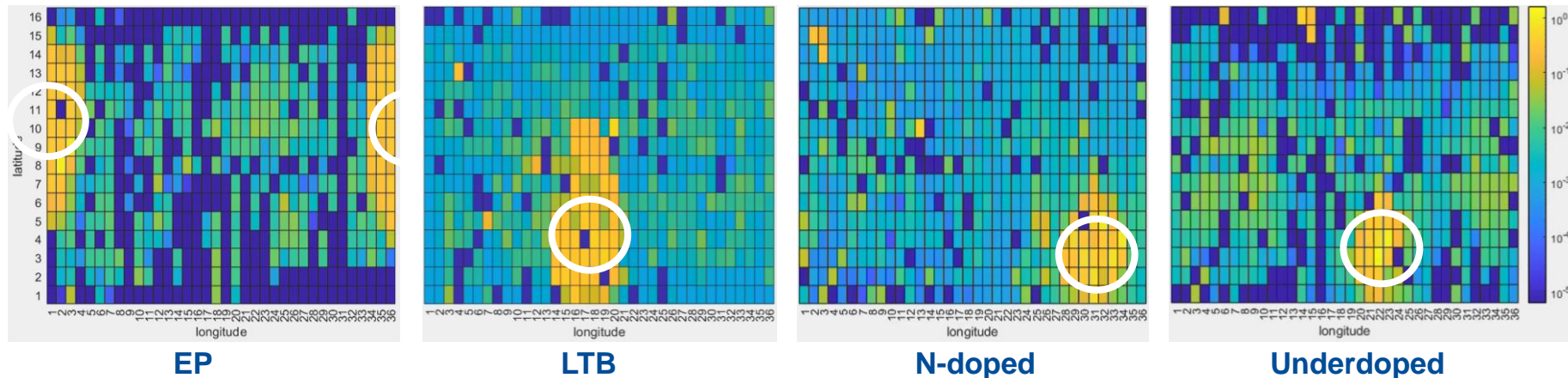


Underdoped





# Comparing TMAPs for All Studied Treatments

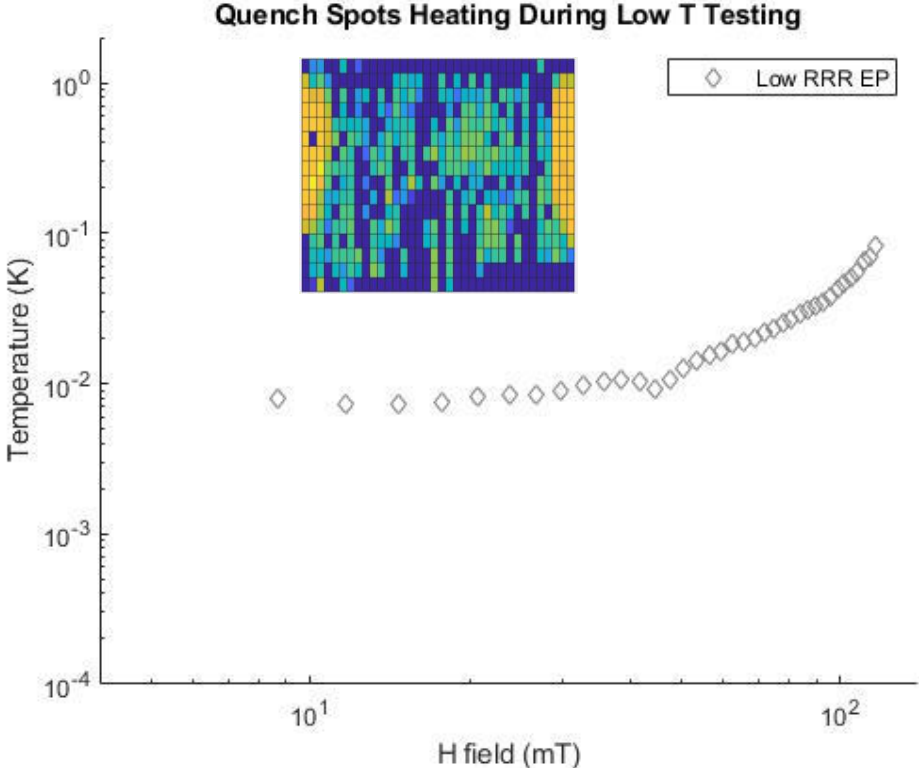


Quench locations change between surface treatments  
Does the heating behavior at the quench locations also change?



# Comparing Quench Spot Heating Profiles

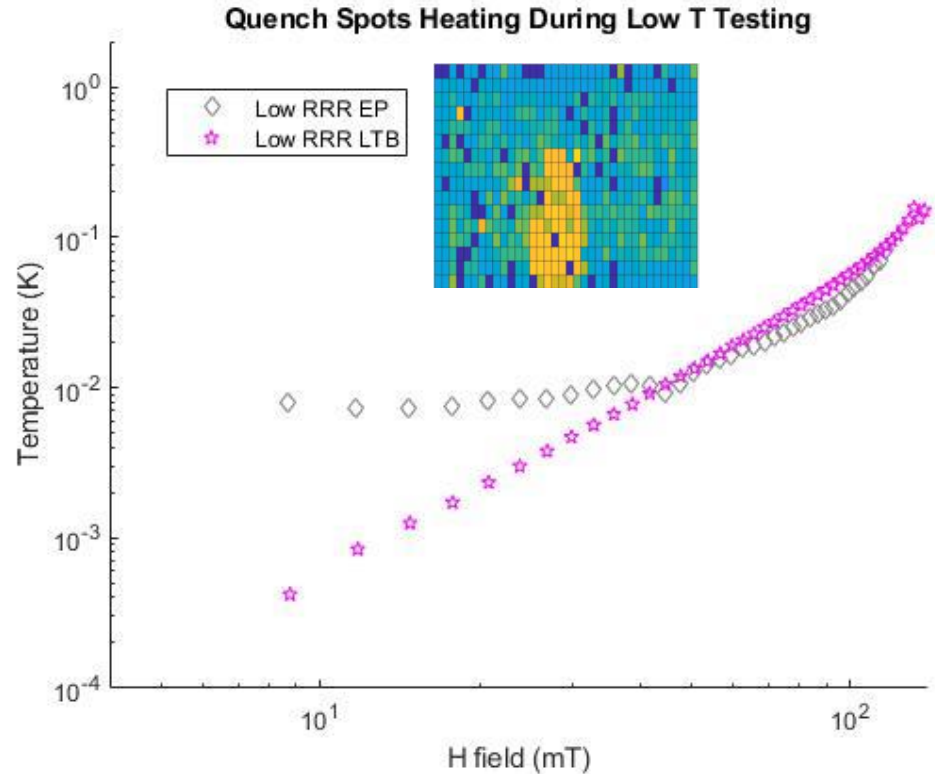
EP: Change in slope corresponds to onset of HFQS



# Comparing Quench Spot Heating Profiles

**EP:** Change in slope corresponds to onset of HFQS

**LTB:** Delay in Q-slope means we do not see onset of additional losses

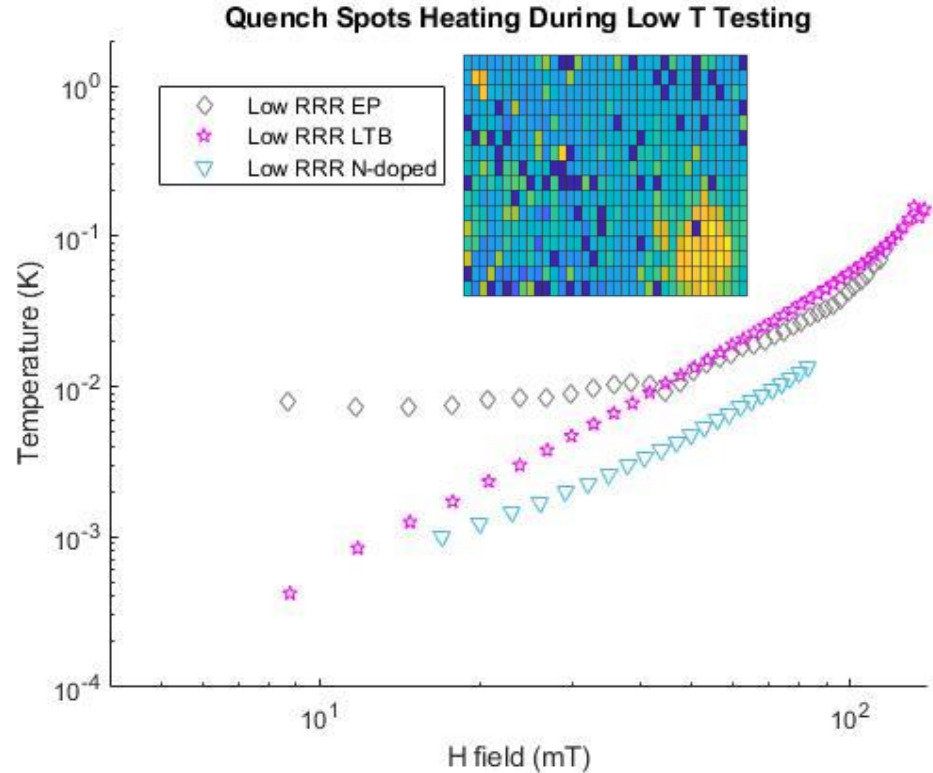


# Comparing Quench Spot Heating Profiles

**EP:** Change in slope corresponds to onset of HFQS

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**N-Doped:** quench of magnetic origin so we do not see change in heating slope



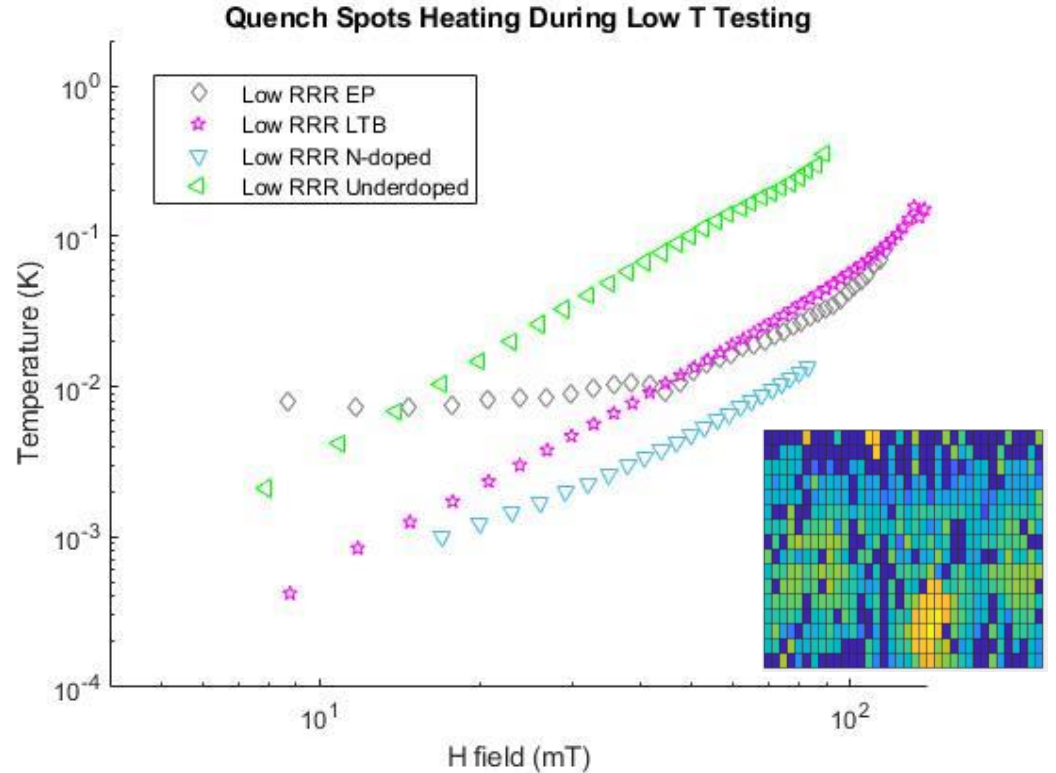
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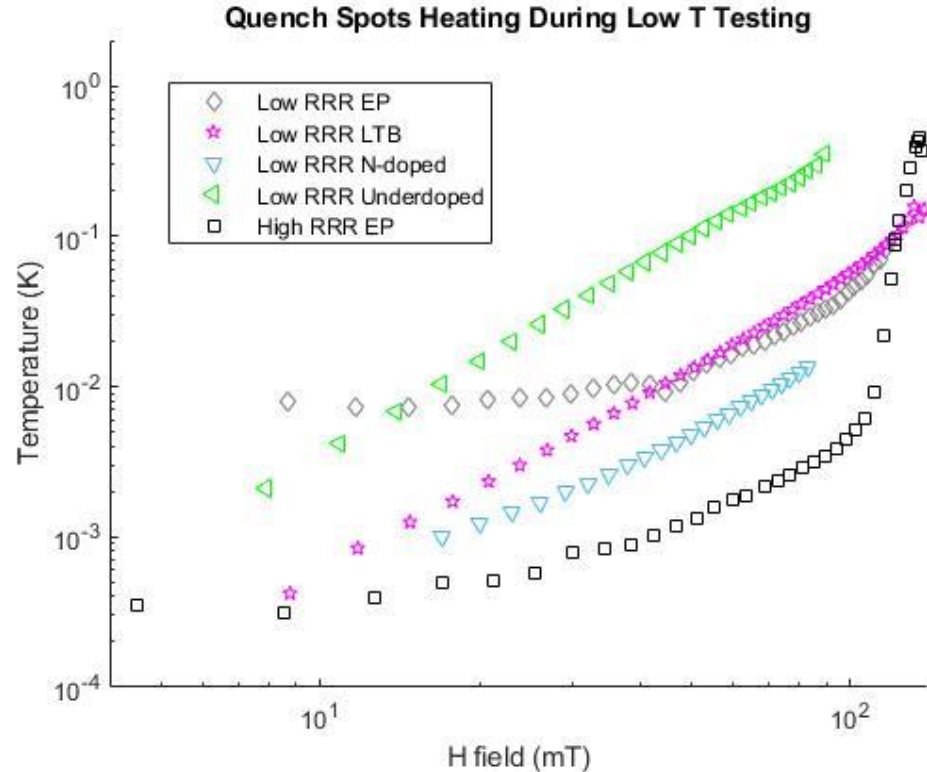
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**N-Doped:** quench of magnetic origin so we do not see change in heating slope

**Underdoped:** Large heating corresponds to large losses

**Compare against high RRR EP:**

- Lower initial heating due to low impurity concentration
- Sharper change in slope than low RRR EP because of stronger HFQS onset (thermal quench)



# Cavity Performance Summary

- Lower quality factors but reach similar gradients
  - $\sim 1.5e10$  at  $\sim 20$  MV/m for 2K
- Larger heating at quench locations but less sudden changes in slope
  - More magnetic quench behavior (less thermal)
- Combined effects of intrinsic and extrinsic impurities

## Next Steps

- Sample Study: identifying key impurity
- Calculation of mean free path from frequency vs temperature data
- N-infusion cavity testing and sample study



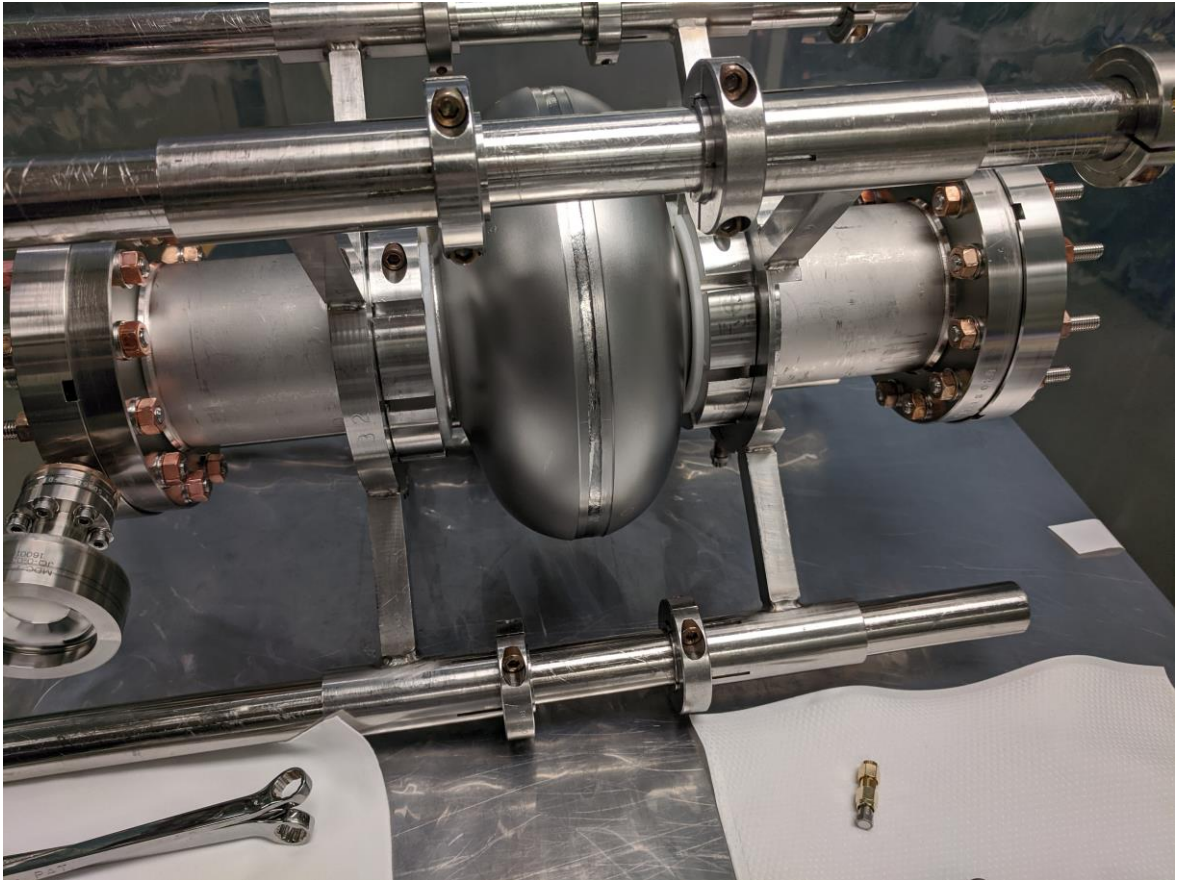
# Discussion Topics

- How was RRR determined and how can we remeasure?
  - Cell material from Tokyo Denkai (Ta Wt % .0193, RRR = 61)
- How might oxygen and nitrogen behave differently in a Nb lattice with more impurities?
- How can intrinsic impurities affect the sensitivity to trapped flux?
  - Especially in N-doped and underdoped

**This manuscript has been authored by Fermi Research Alliance, LLC under Contract No. DE-AC02-07CH11359 with the U.S. Department of Energy, Office of Science, Office of High Energy Physics. This work was supported by the University of Chicago.**



# Extra Slides

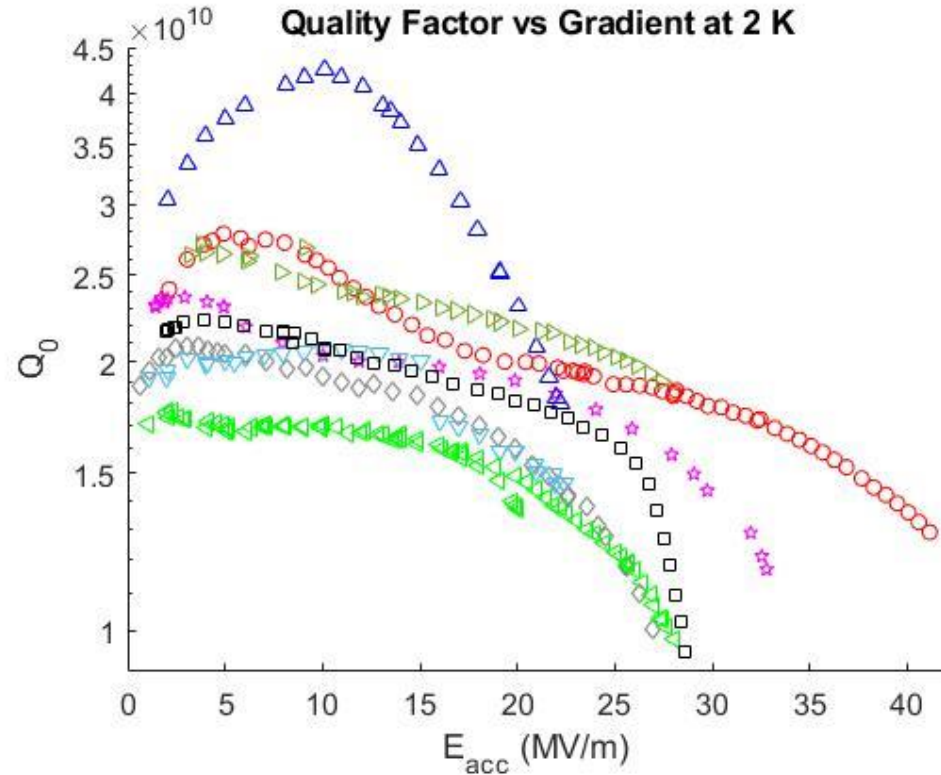




# Quality Factor vs Accelerating Gradient at 2 K

- Performance of EP, LTB, and N-doped are similar at medium gradients
- LTB delays  $Q_0$  slope and reaches highest  $Q_0$  and gradient
- N-doping reaches lowest gradient
- Underdoped has lowest  $Q_0$

	Low RRR	High RRR
EP	◇	□
LTB	☆	○
N-doped	▽	△
Underdoped	◀	▶

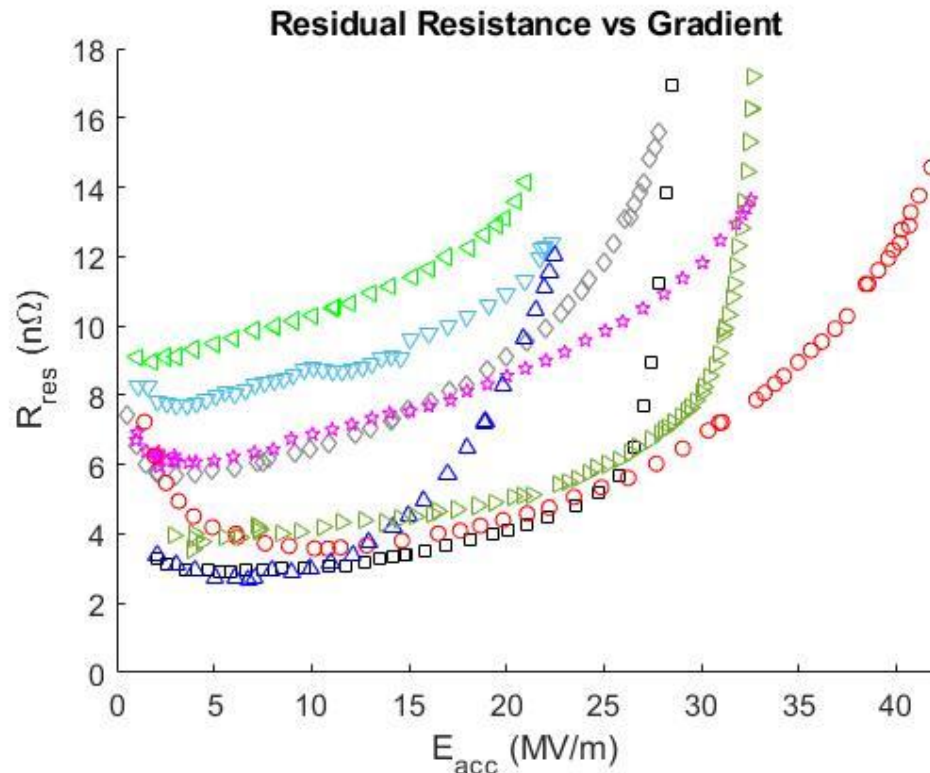


# Residual Resistance vs Accelerating Gradient

$$R_{res} = \frac{G=270 \Omega}{Q_0(low T)}$$

- Low RRR EP and LTB  $R_r$  equal at low and mid fields
- LTB treatment enables smallest increase with gradient
- N-doped  $R_r$  always slightly larger than EP and LTB
- Underdoped shows increase from N-doped

	Low RRR	High RRR
EP	◇	□
LTB	☆	○
N-doped	▽	△
Underdoped	◁	▷



# BCS Resistance vs Accelerating Gradient

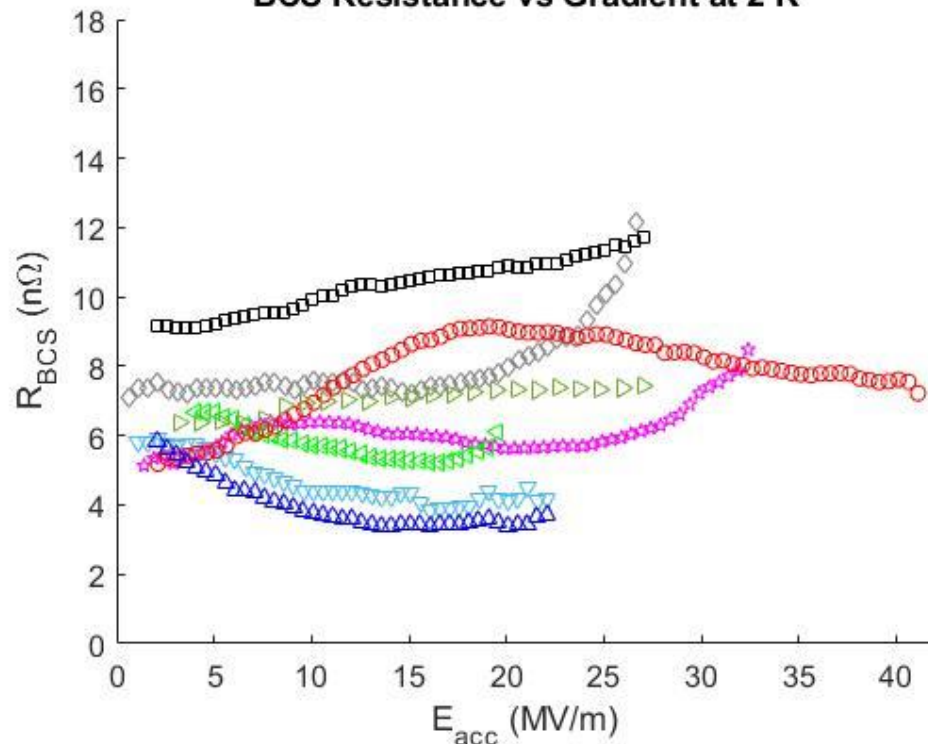
$$R_{BCS}(2 K) = R_s(2 K) - R_{res}$$

Low RRR exhibits low BCS behavior

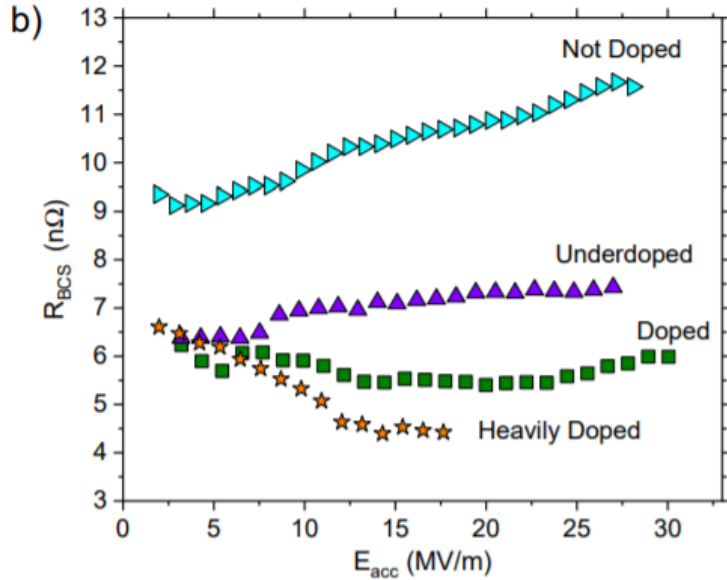
- Low RRR  $R_{BCS}$  is lowest at mid field
- Any benefit of dirty surface is lost at high field in EP and LTB
- N-doped has lower  $R_{BCS}$  than EP and LTB

	Low RRR	High RRR
EP	◇	□
LTB	☆	○
N-doped	▽	△
Underdoped	◁	▷

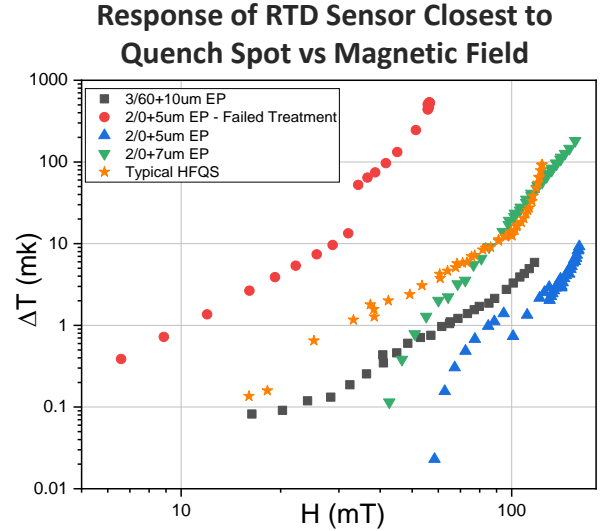
BCS Resistance vs Gradient at 2 K



# Effect of Doping Severity



N-doping severity effect on BCS resistance  
Daniel Bafia's Thesis Fig 6.7b



N-doping severity effect on heating at quench spots  
Daniel Bafia TTC'20